

Notice of References Cited	Application/Control No. 10/098,681	Applicant(s)/Patent Under Reexamination WATANABE ET AL.	
	Examiner David Y. Chung	Art Unit 2871	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,597,427	07-2003	Katsu et al.	349/192
	B	US-6,512,565	01-2003	Lee et al.	349/130
	C	US-5,760,421	06-1998	Takahashi et al.	257/59
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 2000147549 A	05-2000	Japan	KUKIDA et al.	G02F 01/136
	O	JP 2000147538 A	05-2000	Japan	EJIRI, SUNAO	G02F 01/1343
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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